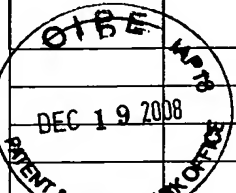


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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449 | Docket No. 52433/783 | Application No. 10/518,664 | |
| | Applicant(s) Akira Usami et al. | Examiner Deborah YEE | |
| | Filing Date December 17, 2004 | Confirmation No. 7856 | Art Unit 1793 |

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| EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |